

Notice of References Cited

Application/Control No.

10/774,454

Applicant(s)/Patent Under
Reexamination
SAITO ET AL.

Examiner

DAVID TUROCY

Art Unit

1792

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Awazu et al. DLC films formed by hybrid pulse plasma coating (HPPC) system. Surface and Coatings Technology 136 2001 pages 172-175.
	V	Hartmann et al. Deposition of thick diamond films by pulsed d.c. glow discharge CVD. Diamond and Related Materials 5 (1996) 850-856.
	W	Tither et al. Hybrid plasma CVD of diamond-like carbon (DLC) at low temperatures. JOURNAL OF MATERIALS SCIENCE 32 (1997) 1931-1936.
	X	Tither et al. Application of diamond-like carbon coatings deposited by plasma-assisted chemical vapour deposition onto metal matrix composites for two-stroke engine components. JOURNAL OF MATERIALS SCIENCE LETTERS 14 (1995) 1062-1064.

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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